

FIG. 1

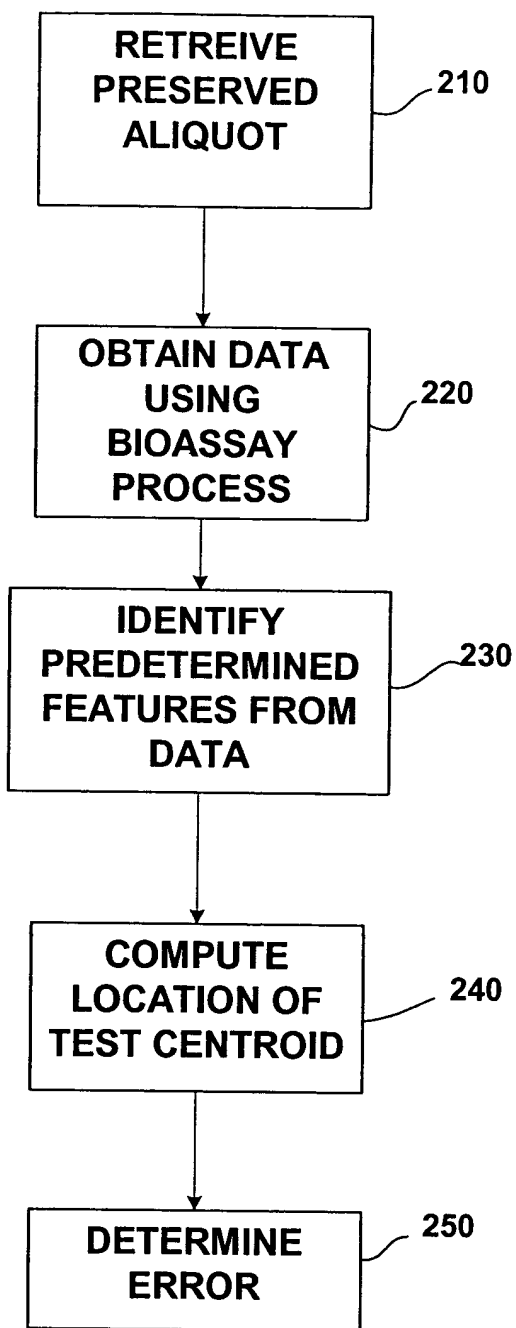


FIG. 2

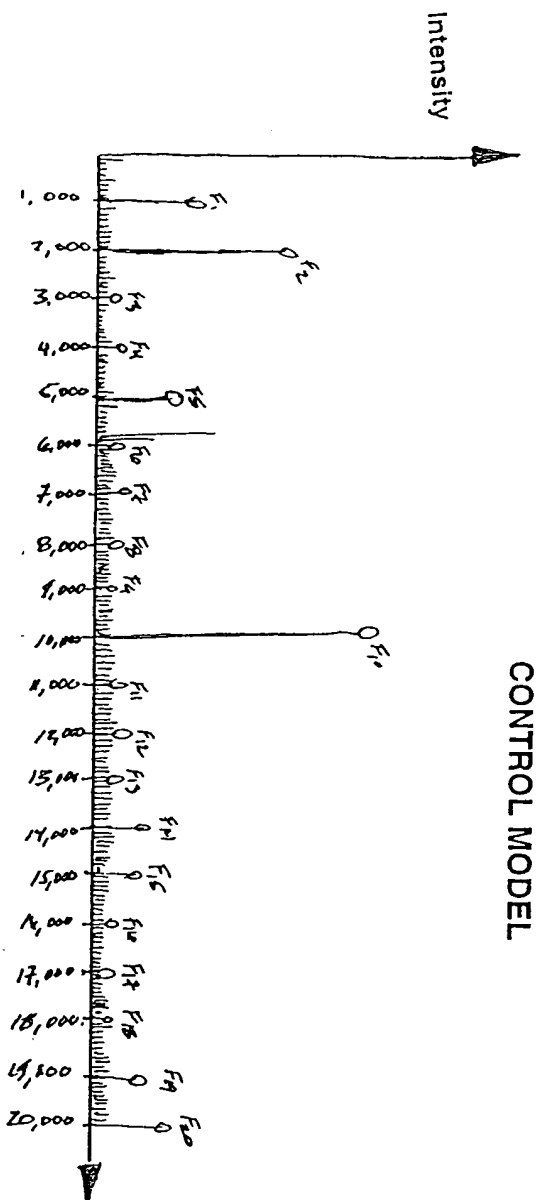


FIG. 3A

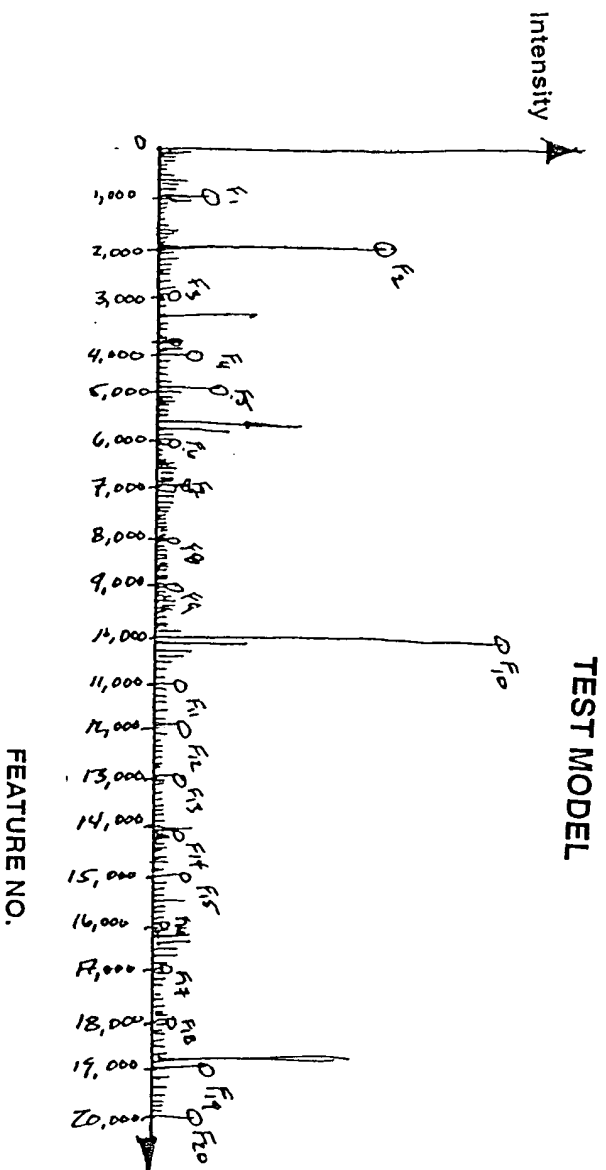


FIG. 3B

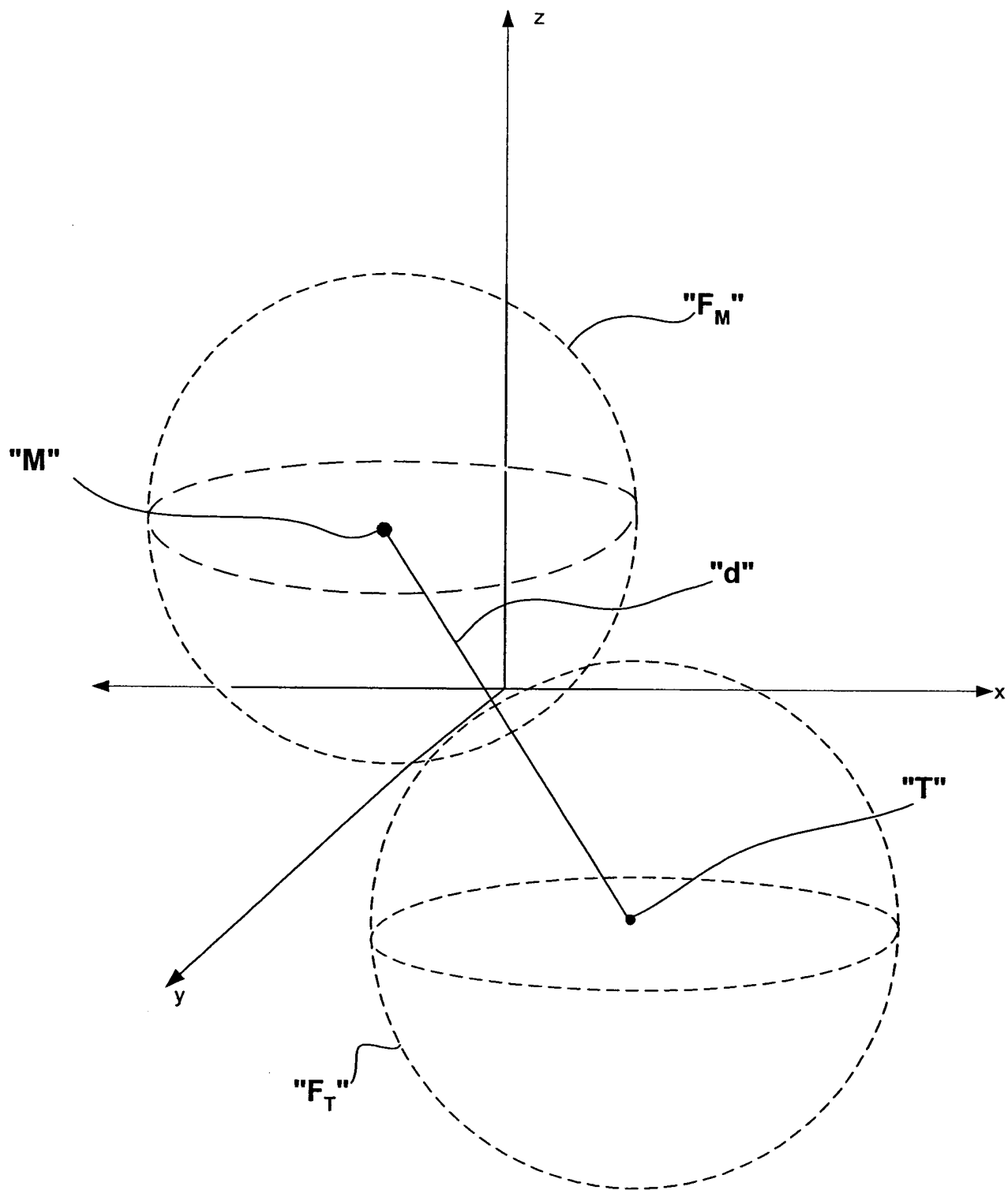


FIG. 4

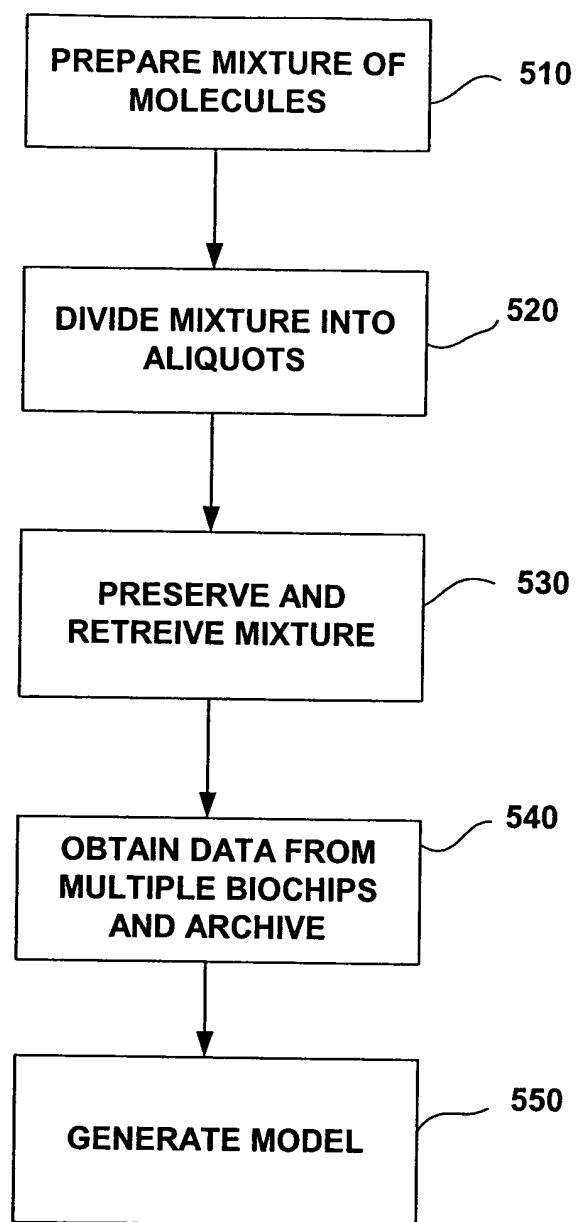


FIG. 5

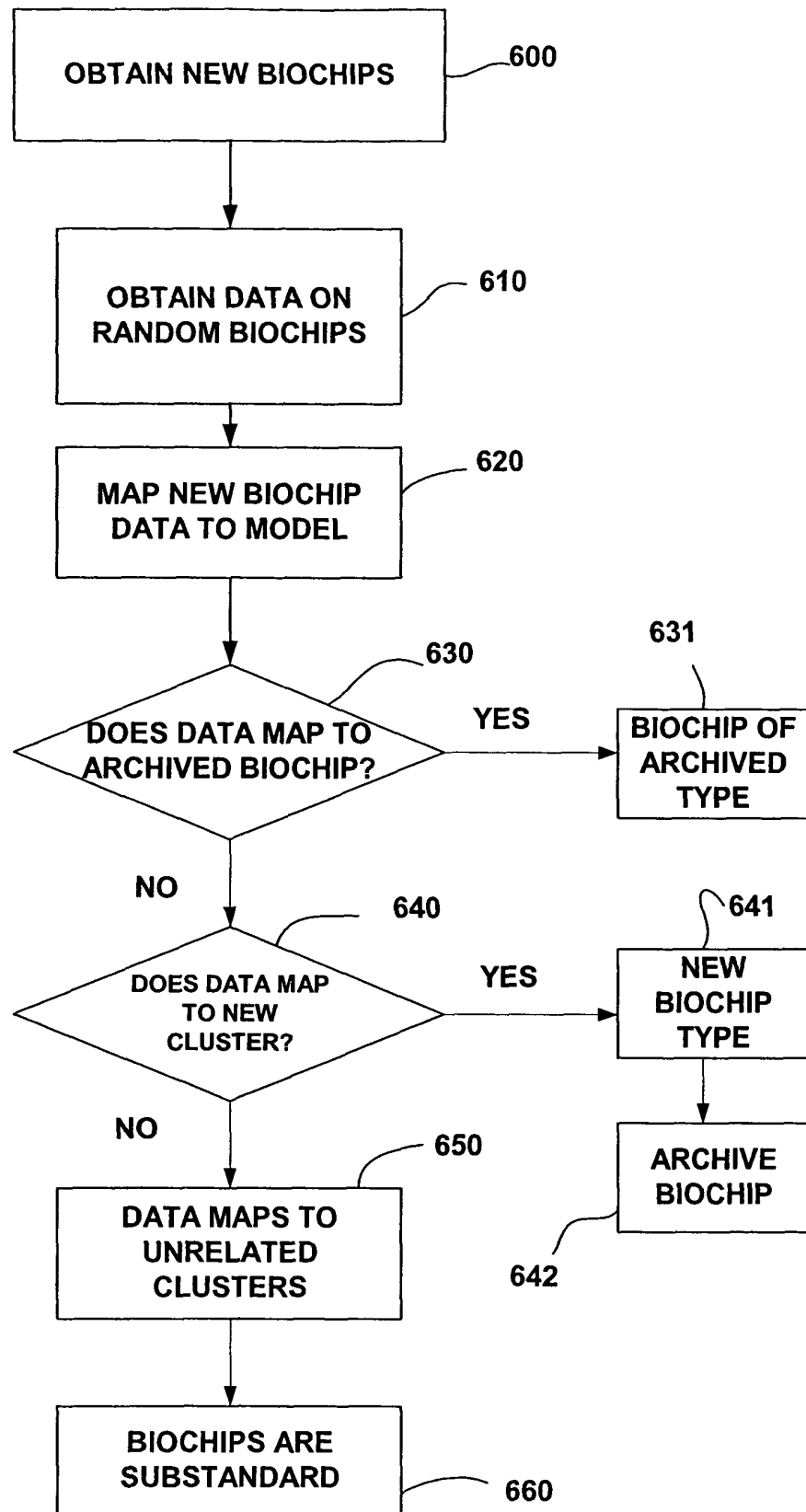


FIG. 6

QA/QC Monitoring Distance to Centroid for Electropray

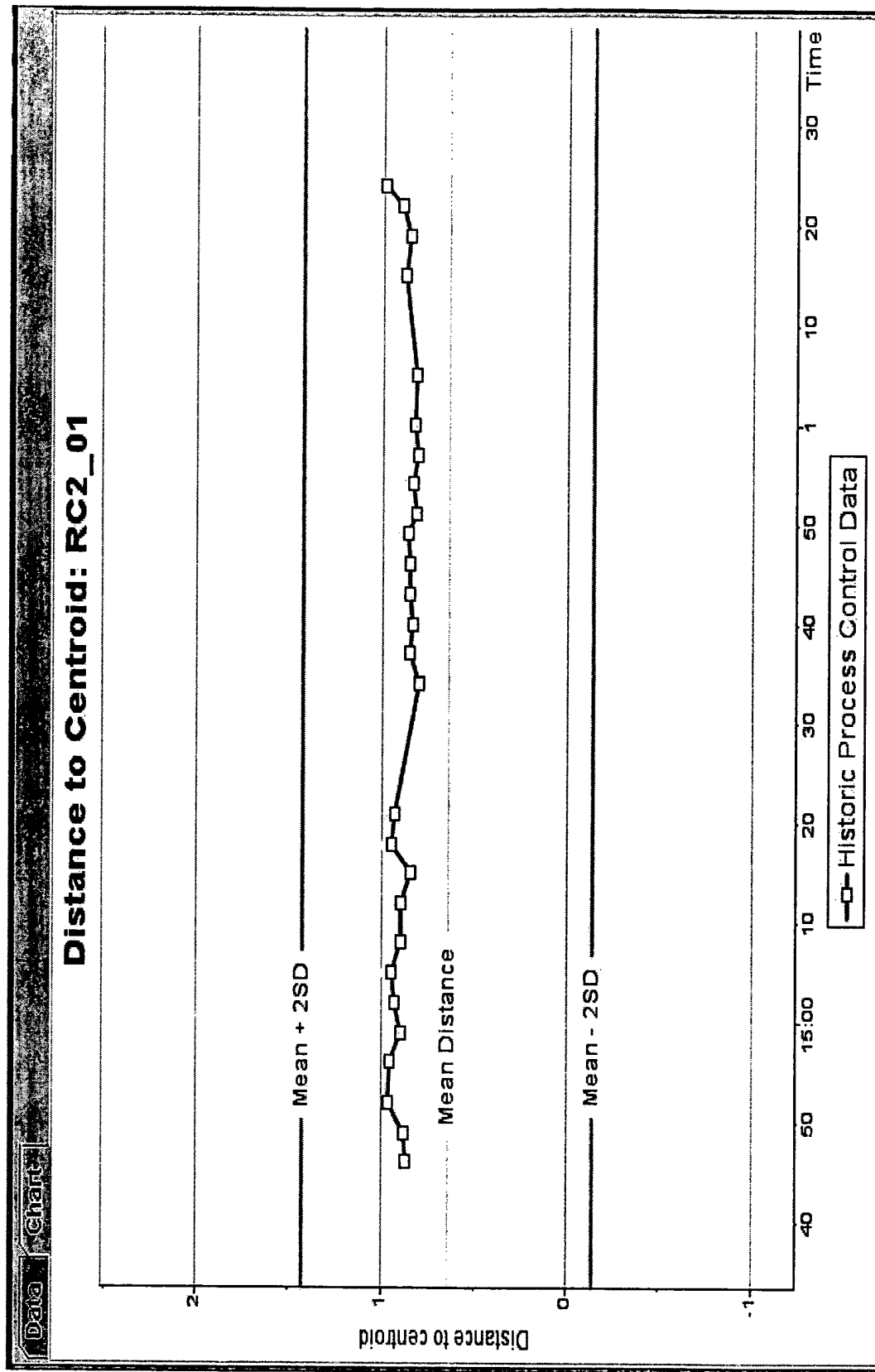
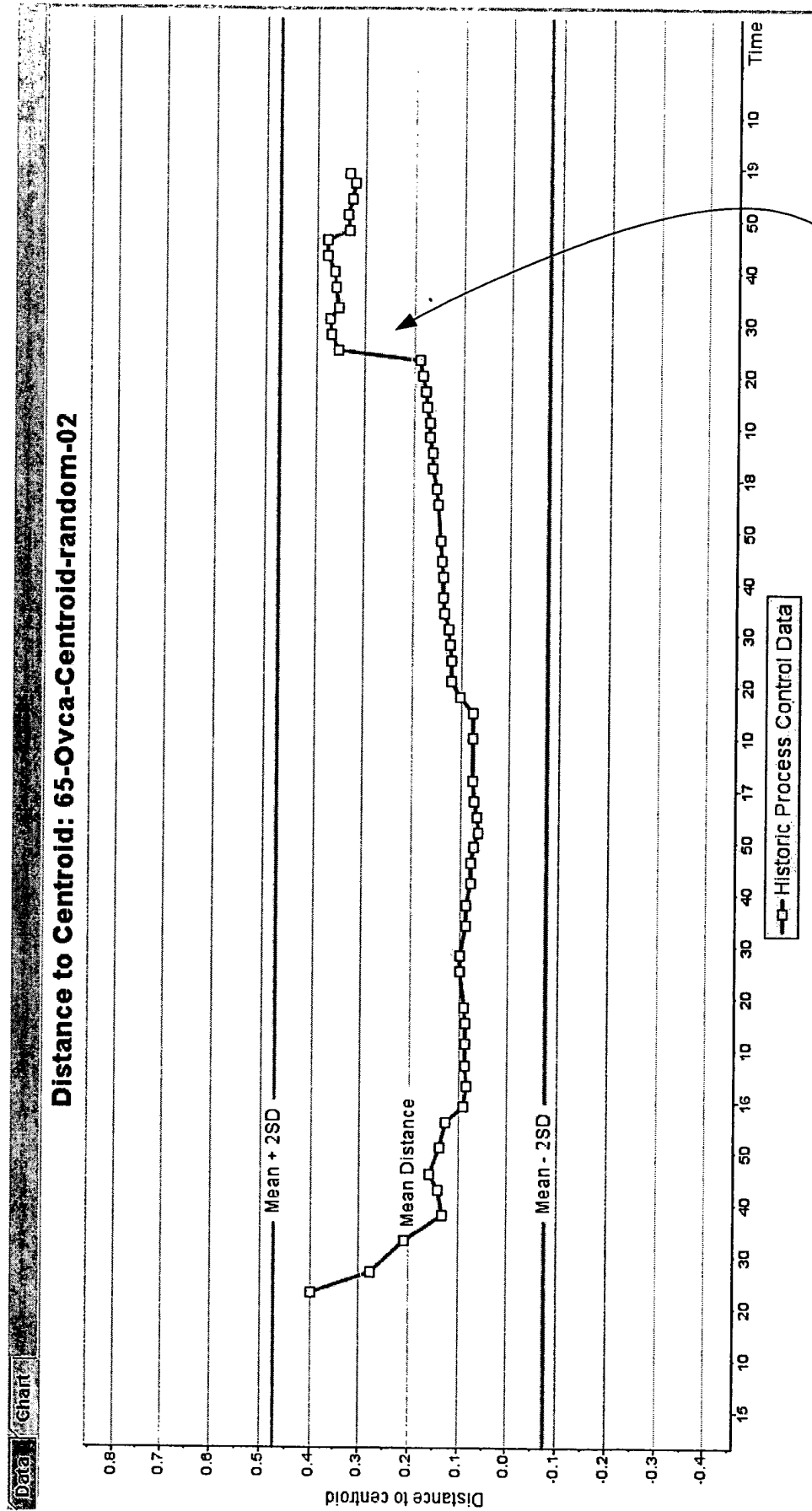


FIG. 7

QA/QC Monitoring Distance to Centroid for SELDI methods



Illustrates that a new
chip has been used

FIG. 8